

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants :Syouji NOGAMI et al.

Group Art Unit : 2813

Appl. No. : 10/562,235

Examiner : Sonya D. McCall Shepard

Filed : October 31, 2006

Confirmation No. : 8539

For : MANUFACTURING METHOD OF SEMICONDUCTOR WAFER  
AND SEMICONDUCTOR WAFER MANUFACTURED BY THIS  
METHOD

**AMENDMENT UNDER 37 C.F.R. § 1.116**

Commissioner for Patents  
U.S. Patent and Trademark Office  
Customer Service Window, Mail Stop **AMENDMENT**  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

In response to the Final Office Action of February 23, 2010, please amend the above application as follows and reconsider the rejections in view thereof. Inasmuch as this response is filed by April 23, 2010, no fee is due for its consideration.

**Amendments to the Claims** are reflected in the listing of claims beginning on page 2.

**Remarks** begin on page 5.